IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

	Haynie	Docket No.:	TI-34351.1
Serial No.:	TBD	Examiner:	TBD
Filed:	10/03/2003	Art Unit:	TBD

For: BLADED SILICON-ON-INSULATOR SEMICONDUCTOR DEVICES AND METHOD OF MAKING

PRELIMINARY AMENDMENT

Honorable Assistant Commissioner of Patents
Washington, D.C. 20231

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Date of Deposit: 10-3-03.

Prior to the examination of the above identified application, please amend the above referenced Application as follows: